|  | Application No.   | Applicant(s)  |           |
|--|---|---|-----------|
|  | 10/767,680  | WILLIAMS ET AL.   |           |
| Notice of Allowability   | Examiner  | Art Unit  |           |
|  | M. Wilczewski   | 2822  |           |
| The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF of the Office or upon petition by the applicant. See 37 CFR 1.313 | (OR REMAINS) CLOSED in or other appropriate common GHTS. This application is s  | n this application. If not included unication will be mailed in due course.   |           |
| 1. 🖾 This communication is responsive to the filing of the instan  | <u>t application</u> .  | •   |           |
| 2. ☑ The allowed claim(s) is/are <u>1</u> .  |   |   |           |
| 3. ⊠ The drawings filed on 28 January 2004 and 01 July 2004 a  | re accepted by the Examine  | er.   |           |
| 4.   | been received.  been received in Application cuments have been received  of this communication to file ENT of this application.  itted. Note the attached EXA es reason(s) why the oath of the submitted on's Patent Drawing Review Amendment / Comment of SA(c)) should be written on the the header according to 37 CF sit of BIOLOGICAL MATI | on No  In this national stage application from a reply complying with the requirement of the complying of the complying of the complete | nts<br>OF |
| Attachment(s)  1. ☑ Notice of References Cited (PTO-892)  2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)  3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date   | 6. ☐ Interview S<br>Paper No.<br>8), 7. ☐ Examiner's  | formal Patent Application (PTO-152)  Jummary (PTO-413),  Mail Date  Amendment/Comment  Statement of Reasons for Allowance  M. Wilczewski  Primary Examiner  Tech Center 2800  |           |

## **EXAMINER'S AMENDMENT**

## **REASONS FOR ALLOWANCE**

The following is an examiner's statement of reasons for allowance: The closest prior art of record is Mametani et al., U.S. Patent 5,478,759. Mametani et al. disclose a method of forming an isolation region that includes the implantation of p-type dopants through field oxide layers to form a retrograde well 61. Mametani et al. also form "sidewalls" in the substrate extending from the bottom of the field oxide layers into the retrograde well 61, see, for example, figures 7(A), 13 and 14. However, Mametani et al. fail to teach or suggest implanting the dopants to form an isolated pocket of the substrate. In addition, Mametani et al. form both the retrograde well and the "sidewalls" in the substrate from dopants which are the same conductivity type as the substrate.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

## Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to M. Wilczewski whose telephone number is (571) 272-1849. The examiner can normally be reached on Monday and Thursday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Amir Zarabian can be reached on 571-272-1852. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Application/Control Number: 10/767,680

Art Unit: 2822

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

M. Wilczewski Primary Examiner Tech Center 2800